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Docket No.: R2180.0193/P193
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naohiro Ueda

Application No.: 10/801,838

Confirmation No.: 3147

Filed: March 17, 2004

Art Unit: 2814

For: SEMICONDUCTOR APPARATUS AND
METHOD OF MANUFACTURING THE
SAME

Examiner: W. M. Fahmy

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: March 17, 2005

Respectfully submitted,

By 

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